



*Imayr*

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: )  
OKU et al ) Examiner: K. Nguyen  
Serial No.: 09/903,764 ) Art Unit: 2823  
Filed: July 13, 2001 )  
For: FILM FORMING METHOD, )  
SEMICONDUCTOR DEVICE AND )  
SEMICONDUCTOR DEVICE )  
MANUFACTURING METHOD )

RESPONSE TO OFFICE ACTION OF DECEMBER 23, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the office action of December 23, 2003, please amend the captioned application as follows: